## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application Commissioner of Patents and Trademarks Washington, D.C. 20231

Re:

Inventor(s):

Manoocher Birang and Shijian Li,

Title:

CHEMICAL MECHANICAL POLISHING WITH FRICTION-BASED CONTROL

Transmitted herewith is the patent application identified above, including:

- <u>X</u> Specification, claims and abstract, totaling (14) pages.
- X Formal Drawings totaling (3) pages
- X Executed Declaration and Power of Attorney.

This application is a divisional application (and claims the benefit of priority under 35 USC 120) of U.S. Application Serial No. 09/562,801, filed on May 2, 2000, which claims priority to U.S. Provisional Application Serial No. 60/132,668 filed May 5, 1999. The disclosures of the priority applications are considered part of ( and are incorporated by reference in) the disclosure of this application.

FEE CALCU	LATION				
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	24	-20=	4	X \$18.00	\$ 72.00
Independent Claims	3	-3=	3	X \$84.00	\$
Basic Filing Fee \$750.00					\$750.00
TOTAL FEES					\$822.00

- The Commissioner is hereby authorized to charge \$822.00 to Deposit Account No. 50-1074 XX
- The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to XXDeposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- $\underline{XX}$ Please address all future correspondence to:

PATENT COUNSEL APPLIED MATERIALS, INC. **Legal Affairs Department** P.O. BOX 450A Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231.

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SEPTEMBER

Respectfully submitted,

Robert W. Mulcahy

Registration No. 25,436